

A novel polishing stop for accurate integration of potassium yttrium double tungstate on silicon dioxide

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RENOS Project

Rare Earth Novel On-chip Sources

Goal: development of high-contrast waveguide fabrication technique in $KY(WO_4)_2$

Why?

- High refractive index ($n \approx 2$ @ 1550 nm)
- Long inter-ionic distance for RE ions ($\langle d \rangle \approx 0.5$ nm) ^[1] and high cross-sections for RE ions ^[2]
- High Raman yield ^[3]

Challenges

- Impossible to grow on most substrates
- Small waveguide dimensions
- Defect free layers



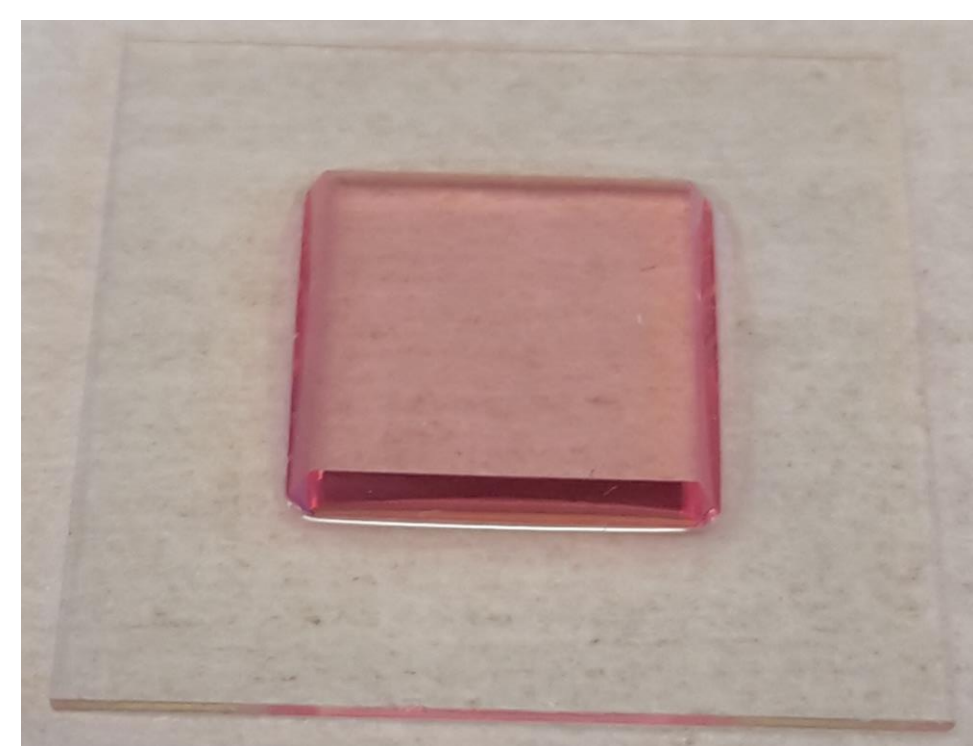
Hybrid integration of $KY(WO_4)_2$

Material

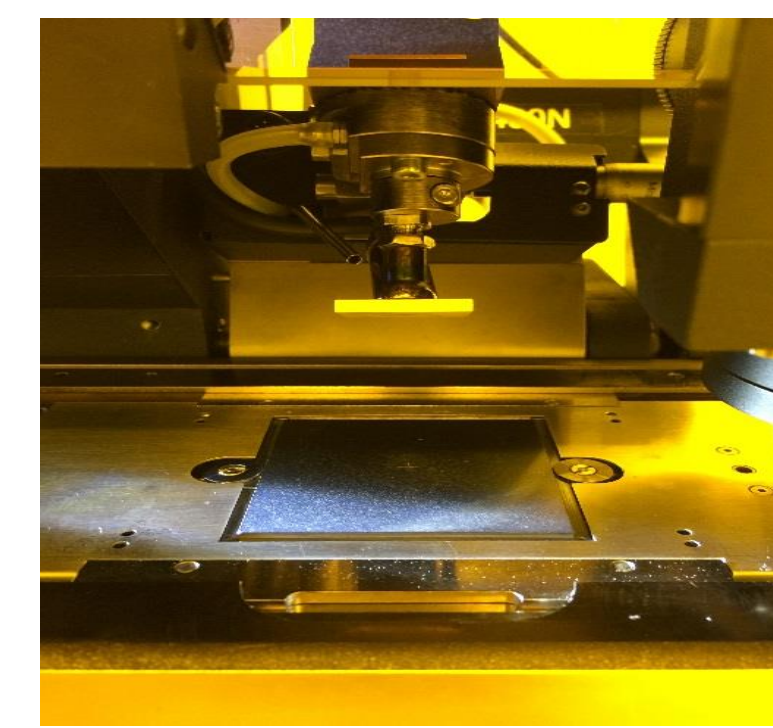
- $KY(WO_4)_2$ crystal 1.0 cm by 1.0 cm, 1.0 mm thick
- SiO_2 substrate 2.0 cm by 2.0 cm, 0.5 mm thick

Goal

- Hybrid integration of $KY(WO_4)_2$ crystal with a final layer thickness of ~ 1 μm .



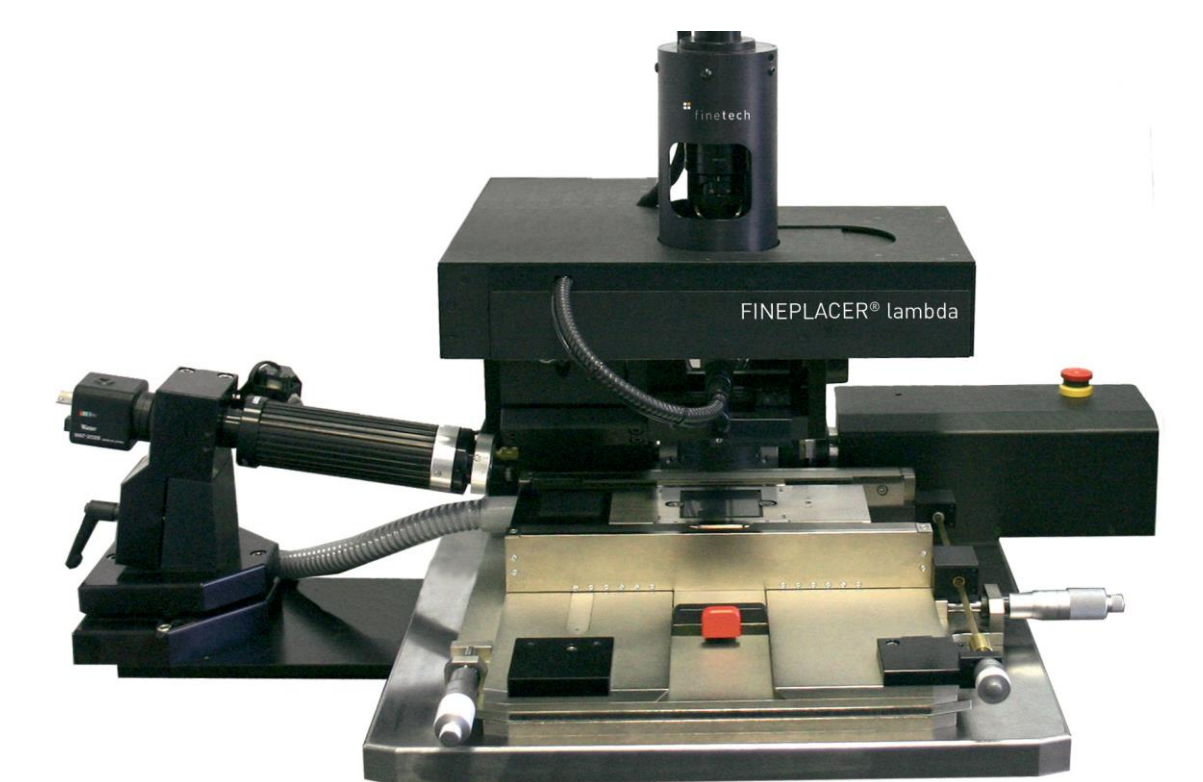
$KY(WO_4)_2$ bonded on a SiO_2 substrate with 6.0 μm wide pillars separated 500.0 μm



Bonding

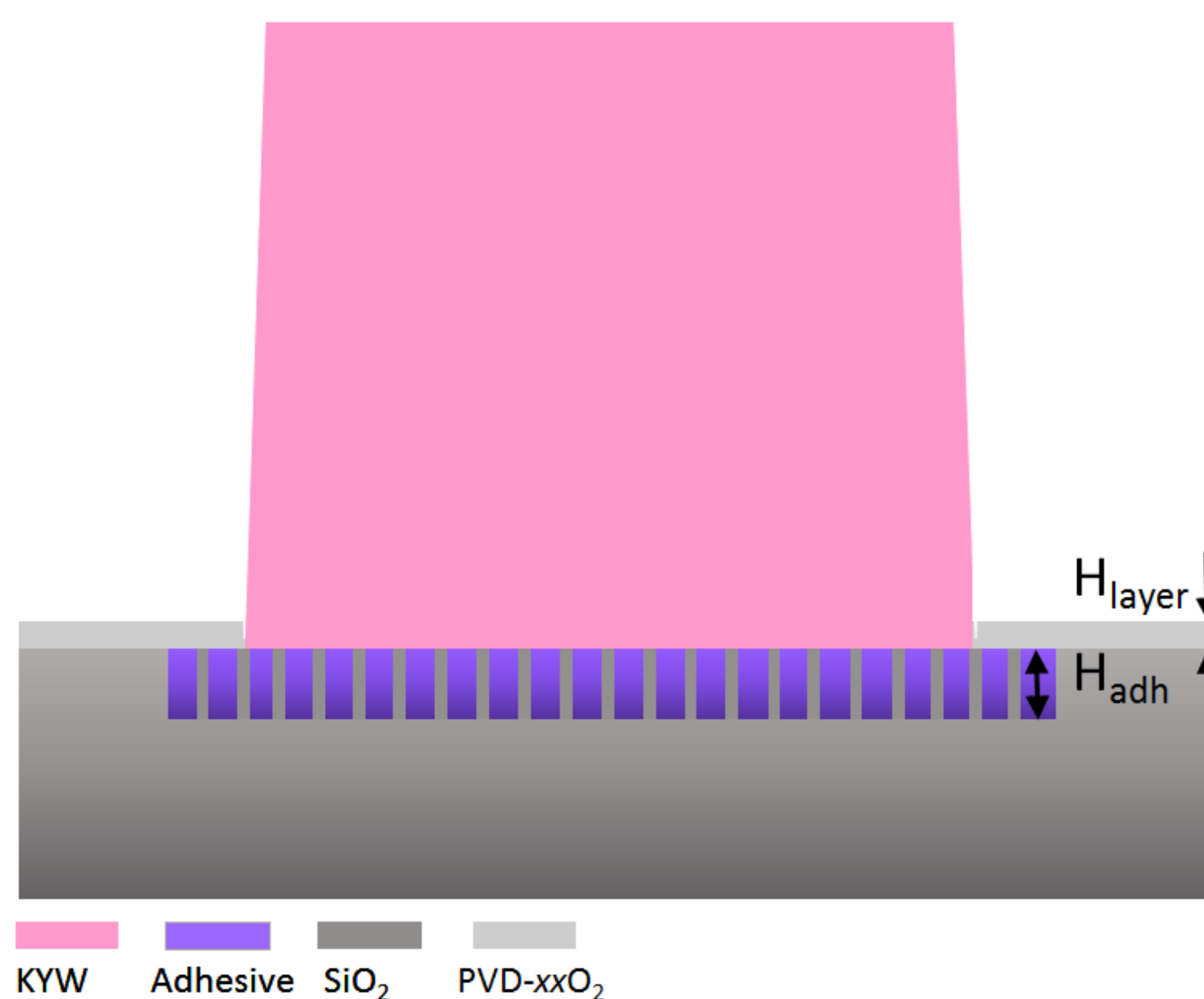
Requirements

- Round beveled KYW edges (to avoid chipping of the edges)
- Low temperature adhesive
- High precision (± 0.1 μm) z-direction



Finetech Fineplacer Lambda precision flip-chip bonder with 0.5 μm X-Y positioning accuracy.

Polishing stop



Schematic representation of a bonded KYW sample with the polishing stop.

Thinning



Logitech PM5 precision lapping and polishing system

Stage	Material
Grinding	400/ 800/ 1000 SiC paste
Lapping	9/ 3/ 1 μm Al_2O_3 suspension on cast iron disk
Polishing	3 μm CeO_2 / 40 nm SiO_2 on polyurethane disk

Fabrication of polishing stop

Requirements

- Hard material
- Room temperature process (to minimize stress due to CTE mismatch of the layers)
- High precision ($H_{layer} \approx 1.0 \pm 0.1$ μm)

Process

Pulsed laser deposition of e.g. TiO_2 , Al_2O_3 at ~ 25 $^{\circ}C$

Results

- Layer as thin as the polishing stop
- Acceptable planarity
- Reduction of polishing speed by 3-4 times
- Higher yield expected

Outlook

- Increase surface quality (RMS < 2.0 nm) for low transmission losses
- Etching of waveguides on thin layer

[1] M. C. Pujol, X. Mateos, R. Sole, J. Massons, J. Gavalda, X. Solans, F. Díaz, and M. Aguilo, "Structure, crystal growth and physical anisotropy of $KYb(WO_4)_2$, a new laser matrix," *J. Appl. Crystallogr.*, no. 35, pp. 108–112, 2002.
 [2] Y.-S. Yong, S. Aravazhi, S. A. Vázquez-Córdova, J. J. Carjaval, F. Díaz, J. L. Herek, S. M. García-Blanco, and M. Pollnau, "Temperature-dependent absorption and emission of potassium double tungstates with high ytterbium content," *Opt. Express*, vol. 24, no. 23, p. 26825, Nov. 2016.

[3] A. A. Kaminskii, A. F. Konstantinova, V. P. Orekhova, A. V. Butashin, R. F. Klevtsova, and A. A. Pavlyuk, "Optical and nonlinear laser properties of the $\chi(3)$ -active monoclinic α - $KY(WO_4)_2$ crystals," *Crystallogr. Reports*, vol. 46, no. 4, pp. 665–672, Jul. 2001.